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P/1250-260

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Tatsufumi KUSUDA et al.

Date Allowed: September 22, 2005

Date: October 21, 2005

Serial No.: 10/661,240

Group Art Unit: 3742

Filed: September 11, 2003

Examiner: Shawntina T. FUQUA

For: PHOTOIRRADIATION THERMAL PROCESSING APPARATUS AND THERMAL  
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Commissioner for Patents  
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Sir:

Enclosed please find a copy of art, along with a form listing the same for the convenience of the Examiner. The present Information Disclosure Statement is being submitted after receipt of a Notice of Allowance, but before payment of the Issue Fee.

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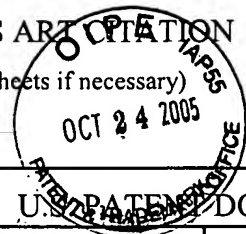
October 21, 2005

Date of Signature

Respectfully submitted,

MAX MOSKOWITZ  
Registration No.: 30,576  
OSTROLENK, FABER, GERB & SOFFEN, LLP  
1180 Avenue of the Americas  
New York, New York 10036-8403  
Telephone: (212) 382-0700

<b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)		Application 10/661,240		OFGS File No. P/1250-260	
		Applicant Tatsufumi KUSUDA et al.			
		Filing Date September 11, 2003		Group Art Unit 3742	



U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
	US-					
	US-					
	US-					
	US-					
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	US-					
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	2000-12370	07-2000	Korea				X
	1999-84603	12-1999	Korea				X

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
	Untranslated Korean Office Action issued August 29, 2005 in connection with
	corresponding Korean application no. 10-2003-0082856
	English statement of Examiner's assertion in 8/29/05 Korean Office Action of the
	relevancy of Korean Application No. 1999-84603 to application no. 10-2003-0082856
	English statement of Examiner's assertion in 8/29/05 Korean Office Action of the
	relevancy of Korean Application No. 2000-12370 to application no. 10-2003-0082856
Examiner	Date Considered

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.